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03500.014179.

PATENT APPLICATION



2879  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of: )  
YOICHI ANDO ET AL. )  
Application No.: 09/722,454 )  
Filed: November 28, 2000 )  
For: METHOD FOR MANUFACTURING )  
ELECTRON BEAM DEVICE, :  
METHOD FOR MANUFACTURING )  
IMAGE FORMING APPARATUS, :  
ELECTRON BEAM DEVICE AND )  
IMAGE FORMING APPARATUS :  
MANUFACTURED THOSE )  
MANUFACTURING METHODS, :  
METHOD AND APPARATUS FOR )  
MANUFACTURING ELECTRON :  
SOURCE, AND APPARATUS FOR )  
MANUFACTURING IMAGE :  
FORMING APPARATUS ) February 18, 2004

RECEIVED

FEB 24 2004

Mail Stop  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

02/20/2004 SSANDARA 00000026 09722454  
01 FC:1806 180.00 0P

For the concise explanation of relevance for non-English document 8-102250, the Examiner is respectfully referred to the English Abstract attached thereto and to English counterparts U.S. Patent 5,847,495 and U.S. Patent Application Publication No. 2002/0132041 A1.

For the concise statement of relevance for all other non-English documents the Examiner is referred to the English abstracts attached thereto.

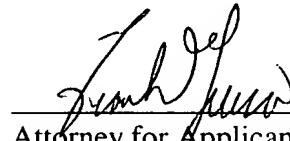
A check for \$180.00 required for consideration of this Information Disclosure Statement is enclosed.

#### CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
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Attorney for Applicants  
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ATTY DOCKET NO.  
03500.014179.

APPLICATION NO.

09/722,454

APPLICANT

YOICHI ANDO ET AL.

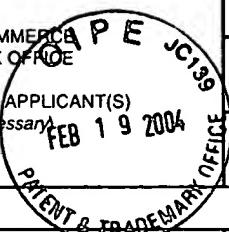
Date Submitted to PTO:[DATE]

FILING DATE

NOVEMBER 28, 2000

GROUP

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## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5,847,495	12/98	Yamanobe et al.	313	310	
	2002/0132041A1	9/02	Yamanobe et al.	427	77	
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	8-102250	4/96	JAPAN			Abstract
	8-162012	6/96	JAPAN	RECEIVED		Abstract
	9-129124	5/97	JAPAN			Abstract
	7-192611	7/95	JAPAN			Abstract
	9-306336	11/97	JAPAN			Abstract
	9-213224	8/97	JAPAN			Abstract
	10-255650	9/98	JAPAN			Abstract
	7-105850	4/95	JAPAN			Abstract
	11-54038	2/99	JAPAN			Abstract

## OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.